210313US2 SRD



<u>IN THE UNITED STATES PATENT & TRADEMARK OFFICE</u>

IN RE APPLICATION OF

Akira NISHIYAMA, et al

: EXAMINER: MAI, A.D.

SERIAL NO: 09/891,129

FILED: June 26, 2001

: GROUP ART UNIT: 2814

FOR: SEMICONDUCTOR DEVICE AND METHOD...

LETTER REQUESTING APPROVAL OF DRAWING CHANGES

ASSISTANT COMMISSIONER FOR PATENTS WASHINGTON, D.C. 20231

SIR: JO

Please review for approval the proposed changes to Figures 1, 2A, 2B as

shown in red on the attached photocopies of the Figures.

NI

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND, MAIER & NEUSTADT, P.C.

22850

Tel. (703) 413-3000 Fax. (703) 413-2200 GJM:SS:SKK:dnf

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Gregory J. Maier

Registration No. 25,599

Surinder Sachar

Registration No. 34,423

Attorneys of Record

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